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<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty Docket No. CISCP035	Application No.: 09/089,312
	Applicant: Findlater, et al.	
	Filing Date 6/2/98	Group <b>2661</b> Unassigned

**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
	A						
	B						
	C						
	D						
	E						
	F						
	G						
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	I						
	J						
	K						

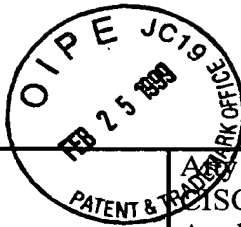
**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub- class	Translation	
							Yes	No
	L							
	M							
	N							
	O							
	P							

**Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
TA.	R	RMII Consortium, "RMII Specification," (Mar. 20, 1998).
	S	
	T	
Examiner	Anthony Ton	
	Date Considered	12/5/00

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



#6

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Applicant Docket No. USPCP035	Application No.: 09/089,312
	Applicant: Findlater, et al. Filing Date 6/2/98	Group <b>2661</b> Unassigned

**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
TA.	A	5,568,470	10/22/96	Ben-Nun et al.	<b>370</b>	<b>238</b>	4/28/95
TA.	B	5,099,473	3/24/92	Gupta et al.	<b>370</b>	<b>434</b>	7/20/90
TA.	C	5,636,140	6/3/97	Lee et al.	<b>370</b>	<b>469</b>	8/25/95
TA.	D	5,835,728	11/10/98	Shinomiya et al.	<b>709</b>	<b>242</b>	9/19/97
TA.	E	5,856,979	1/5/99	Vogel et al.	<b>370</b>	<b>503</b>	3/21/97
TA.	F	5,715,287	3/2/98	Wadhawan et al.	<b>375</b>	<b>377</b>	10/18/95
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**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
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	L							
	M							
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**Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
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	T	
Examiner <b>Anthony Ton</b>		Date Considered <b>12/04/00</b>

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.